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SERIAL NUMBER	REQUEST DATE	FIRST NAMED APPLICANT	ATTORNEY DOCKET NO.
10/664,755	10/10/03	KUO-CHING LIU	NWAV 1002-2

Title:
**METHOD AND APPARATUS FOR CUTTING DEVICES FROM
SUBSTRATES**

Art Unit	Paper Number
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Grant Date: 14-Oct-03

Approved:


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LICENSE FOR FOREIGN FILING

[Title 35, United States Code (1952) Sections 184, 185, 186]

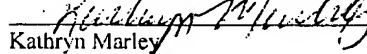
Application No. 10/664,755

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1460-130.00

CERTIFICATE OF TRANSMISSION UNDER 37 CFR 1.8

I hereby certify that this correspondence is being facsimile transmitted to United States Patent and Trademark Office at Fax No. (703) 305-7658 on 10 October 2003.


Kathryn Marley

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Kuo-Ching Liu

Application No.: **10/664,755**

Filed: **17 September 2003**

Title: **METHOD AND APPARATUS FOR CUTTING DEVICES FROM SUBSTRATES**

Examiner: Unknown

Art Unit: Unknown

CUSTOMER NO. 22470

Foreign Filing Department
Commissioner for Patents
Crystal Park 5, 3D11
P.O. Box 1450
Alexandria, VA 22313-1450

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OCT 10 2003
LICENSING & REVIEW

PETITION FOR LICENSE UNDER 37 CFR §5.14;
CORRESPONDING U.S. APPLICATION

Sir:

Applicant petitions for an **Expedited** Foreign Filing License on the above-identified application.

Pursuant to 37 C.F.R. Section 5.14, Applicant submits herewith a copy of the application which is to be filed in foreign countries. The specification differs from the above-referenced specification on file only to the extent that whenever "conductive" is referenced in the specification on file, the specification for foreign filing replaces conductive with "conductive or semiconductive." The claims differ only in that there are additional claims which have been filed in a prior application for which a foreign filing license has already been granted (Application Serial No. 10/288,719).

A PTO Form 2038 is enclosed herewith submitting \$130 to cover the petition fee pursuant to 37 C.F.R. Section 1.17(h).

It is requested that the License be faxed to the undersigned Mark A. Haynes at (650) 712-0263.

Application No. 10/664,755

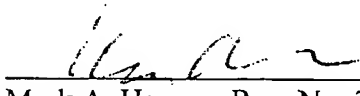
NWAV 1002-2

The Commissioner is hereby authorized to charge any additional fees which may be due, or credit any overpayment, to our Deposit Account No. 50-0869 (Order No. NWAV 1002-2).

Respectfully submitted,

Dated: 10 October 2003

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